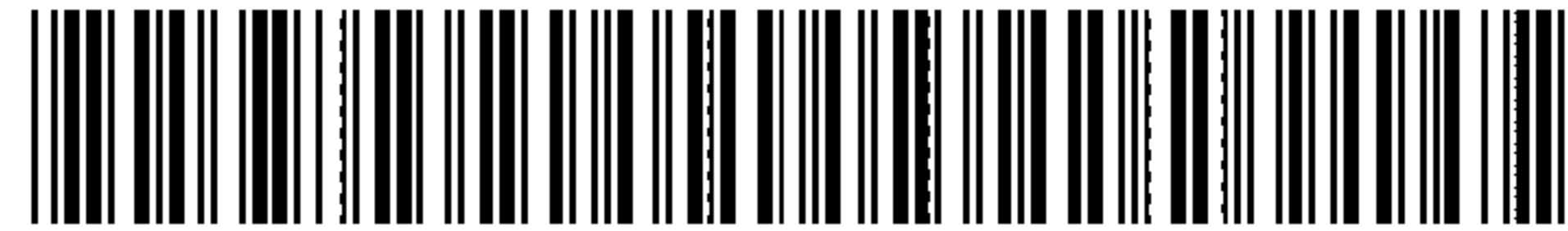


(19)



Europäisches Patentamt
European Patent Office
Office européen des brevets



(11)

EP 1 410 433 B1

(12)

EUROPEAN PATENT SPECIFICATION

(45) Date of publication and mention
of the grant of the patent:
23.03.2005 Bulletin 2005/12

(21) Application number: **02787170.6**

(22) Date of filing: **16.07.2002**

(51) Int Cl.7: **H01L 21/332**

(86) International application number:
PCT/IT2002/000465

(87) International publication number:
WO 2003/009317 (30.01.2003 Gazette 2003/05)

(54) **SUPPORT WITH INTEGRATED DEPOSIT OF GAS ABSORBING MATERIAL FOR
MANUFACTURING MICROELECTRONIC, MICROOPTOELECTRONIC OR MICROMECHANICAL
DEVICES**

TRÄGER MIT INTEGRIERTER ABSCHIEDUNG VON GASABSORBIERENDEM MATERIAL ZUR
HERSTELLUNG VON MIKROELEKTRONISCHEN, MICROOPTOELEKTRONISCHEN ODER
MIKROMECHANISCHEN BAUELEMENTEN

SUPPORT AVEC DEPOT INTEGRE DE MATERIAU ABSORBANT LES GAZ POUR LA
FABRICATION DE DISPOSITIFS MICROELECTRONIQUES, MICROOPTOELECTRONIQUES ET
MICROMECHANIQUES

(84) Designated Contracting States:
**AT BE BG CH CY CZ DE DK EE ES FI FR GB GR
IE IT LI LU MC NL PT SE SK TR**

(30) Priority: **20.07.2001 IT MI20011557**
03.04.2002 IT MI20020689

(43) Date of publication of application:
21.04.2004 Bulletin 2004/17

(73) Proprietor: **SAES GETTERS S.p.A.**
20020 Lainate (Milano) (IT)

(72) Inventor: **AMIOTTI, Marco**
I-27029 Vigevano (IT)

(74) Representative: **Adorno, Silvano et al**
c/o SOCIETA' ITALIANA BREVETTI S.p.A.
Via Carducci, 8
20123 Milano (IT)

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